

U.S. Patent Application Serial No.: 10/027,856

Filed: October 19, 2001 Assignee: Rohm Co., Ltd.

Title of the Invention: SEMICONDUCTOR DEVICE AND METHOD OF MAKING

THE SAME

DECLARATION

I, Kyoko NAKAGAWA, hereby declare:

that I am a translator belonging to KYOWEY INT'L of 2-32-1301 Tamatsukuri-Motomachi, Tennoji-ku, Osaka, 543-0014 Japan; that I am well acquainted with both the Japanese and English languages;

that I have prepared an English translation of the Japanese language specification, claims and abstract as originally filed with the U.S. Patent and Trademark Office; and

that the said English translation corresponds to the said Japanese language specification, claims and abstract to the best of my knowledge.

I also declare that all statements made herein of my knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statements is directed.

Declared at Osaka, Japan on February 25, 2002 By Kyoko NAKAGAWA

Signature

Hyoko Makagawa